



# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Application No.	09/783,122
Filing Date	Feb. 14, 2001
Inventor	Kian et al.
Art Unit	2871
Examiner	
Atty. Docket No.	081400-006

Sheet 1 of 1

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Examiner  
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<b>FORM PTO-1449 (Modified)</b>	Docket No.: 081400-006	Serial No.: Unassigned
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Applicant: Kian et al. #2	1107 U.S. PTO 09/783122 02/14/01
	Filing Date: February 14, 2001	

### UNITED STATES PATENT DOCUMENTS

*Exr's. Inits.	Ref.	Patent No.	Date	Name	Class	Sub Class	Filing Date (if applicable)
BT	AA	4,166,876	09/04/79	Chiba et al.	428	215	
BT	AB	4,234,654	11/18/80	Yatabe et al.	428	333	
BT	AC	4,458,994	07/10/84	Jain et al	354	4	
BT	AD	4,734,174	03/29/88	Venis, Jr.	204	129.5	
BT	AE	4,773,750	09/27/88	Bruning	353	122	
BT	AF	4,927,493	05/22/90	Yamazaki et al.	156	643	
BT	AG	4,970,366	11/13/90	Imatou et al.	219	121.68	
BT	AH	5,034,795	07/23/91	Henry	357	30	
BT	AI	5,062,916	11/05/91	Aufderheide et al.	156	269	
BT	AJ	5,311,533	05/10/94	Stutius et al.	372	46	
BT	AK	5,320,918	06/14/94	Raab et al.	430	4	
BT	AL	5,322,876	06/21/94	Sasaki et al.	524	366	

### FOREIGN PATENT DOCUMENTS

Exr's. Init.	Ref	Document No.	Date	Country	Class	Sub	Translation? Yes No
BT	AM	02037326 A	02/07/90	Japan			X
BT	AN	WO95/22881	08/24/95	PCT			
BT	AO	EP0699375B1	03/06/96	Europe			
BT	AP	EP0733931A2	09/25/96	Europe			

### OTHER REFERENCES (Including Author, Date, Title, Pertinent Pages, Etc.)

Exr's. Inits.	Ref.	Bibliographic Data
BT	AQ	R.E. Sheets and H.G. Muller, "Scanning Projection Tools for Large Area Thin Film Displays," 1994 Display Manufacturing Technology Conference Digest of Technical Papers, SID, p. 97-98 (1994).
BT	AR	C.W. Laasko and W.A. Barrow, "Use of a Scanning Projection Exposure Tool in Fabrication of Full Color TFEL Displays," 1995 Display Manufacturing Technology Conference Digest of Technical Papers, SID, p. 101-102 (1995).
BT	AS	H. Endert and U. Leinhos, "Excimer Lasers: A New, Powerful Tool for Microstructuring," LIGA news Third Issue, September 1995.

Examiner

Binh Tran

Date Considered

1/22/03

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<b>UNITED STATES PATENT DOCUMENTS</b>							
*Exr's. Inits.	Ref.	Patent No.	Date	Name	Class	Sub Class	Filing Date (if applicable)
BT	BA	5,530,516	06/25/96	Sheets	355	53	
BT	BB	5,512,148	04/30/96	Smith, Jr. et al.	204	192.23	
BT	BC	5,514,618	05/07/96	Hunter, Jr. et al.	437	60	
BT	BD	5,625,477	04/29/97	Wu et al.	349	35	
BT	BE	5,661,533	08/26/97	Wu et al.	349	169	
BT	BF	5,667,853	09/16/97	Fukuyoshi et al.	428	1	
BT	BG	5,702,565	12/30/97	Wu et al.	156	643.1	
BT	BH	5,703,436	12/30/97	Forrest et al.	313	506	
BT	BI	5,705,551	01/06/98	Sasaki et al.	524	366	
BT	BJ	5,714,404	02/03/98	Mitlitsky et al.	437	233	
BT	BK	5,726,524	03/10/98	Debe	313	309	
BT	BL	Re. 35,753	03/24/98	Raab et al.	430	4	
<b>FOREIGN PATENT DOCUMENTS</b>							
Exr's. Init.	Ref	Document No.	Date	Country	Class	Sub	Translation? Yes      No
BT	BM	09152618A	06/10/97	Japan			x
BT	BN	09171188A	06/30/97	Japan			x
BT	BO	WO99/36261-7	07/22/99	PCT			
BT	BP	WO99/42860	08/26/99	PCT			
<b>OTHER REFERENCES (Including Author, Date, Title, Pertinent Pages, Etc.)</b>							
Exr's. Inits.	Ref.	Bibliographic Data					
BT	BQ	R.E. Sheets, "Scanning projection for large-area lithography," <i>Microlithography World</i> , Spring 1996.					
BT	BR	D.E. Rector and M.H. Boothman, "Modern Manufacture of Large Area Photomasks," <i>1997 Display Manufacturing Technology Conference Digest of Technical Papers</i> , SID, p. 39-40 (1997).					
BT	BS	F.E. Doany et al., "Large-field scanning laser ablation system," <i>IBM Journal of Research and Development</i> , Vol. 41, No. 1/2, 1997.					
Examiner <u>B. M. Tran</u>		Date Considered <u>1/22/03</u>					
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*Exr's. Inits.	Ref.	Patent No.	Date	Name	Class	Sub Class	Filing Date (if applicable)
BT	CA	5,796,454	08/18/98	Ma	349	98	
BT	CB	5,817,550	10/06/98	Carey et al.	438	166	
BT	CC	5,825,451	10/20/98	Ma et al.	349	187	
BT	CD	5,856,858	01/05/99	Carey et al.	349	158	
BT	CE	5,889,566	03/30/99	Wu et al.	349	35	
BT	CF	5,933,203	08/03/99	Wu et al.	349	35	
BT	CG	5,949,513	09/07/99	Ma et al.	349	187	
BT	CH	5,969,803	10/19/99	Mercado	355	67	
BT	CI	5,986,824	11/16/99	Mercado	359	754	
BT	CJ	5,990,926	11/23/99	Mercado	347	258	
BT	CK	6,020,941	02/01/00	Ma	349	15	
	CL						
<b>FOREIGN PATENT DOCUMENTS</b>							
Exr's. Init.	Ref	Document No.	Date	Country	Class	Sub	Translation? Yes      No
BT	CM	WO99/51386	10/14/99	PCT			
	CN						
	CO						
	CP						
<b>OTHER REFERENCES (Including Author, Date, Title, Pertinent Pages, Etc.)</b>							
Exr's. Inits.	Ref.	Bibliographic Data					
BT	CQ	P.Y.Z. Chu et al., "42.2: A New Conductor Structure for Plastic LCD Applications Utilizing 'All Dry' Digital Laser Patterning," 1998 <i>SID International Symposium Digest of Technical Papers, Anaheim, CA, May 17-22, 1998</i> , Vol. 29, No. 1, 17 May 1998, pages 1099-1101.					
BT	CR	A. Heller, "Flat-Panel Displays Slim Down with Plastic," <i>Science and Technology Review</i> , November, 1999.					
BT	CS	Tamarack Scientific Co., Inc., "Large area scanning projection exposure systems," brochure, published October 2000.					
Examiner: <u>B. H. Tran</u>		Date Considered: <u>1/22/03</u>					
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	DA						
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<b>FOREIGN PATENT DOCUMENTS</b>							
Exr's. Init.	Ref.	Document No.	Date	Country	Class	Sub	Translation? Yes      No
	DM						
	DN						
	DO						
	DP						
<b>OTHER REFERENCES (Including Author, Date, Title, Pertinent Pages, Etc.)</b>							
Exr's. Inits.	Ref.	Bibliographic Data					
BT	DQ	Tamarack Scientific Co., Inc., "Excimer Laser Ablation Systems," brochure, published October 2000.					
BT	DR	Resonetics, Inc., "Laser Micromachining in Contract Manufacturing," <a href="http://www.resonetics.com/contractMFG.htm">http://www.resonetics.com/contractMFG.htm</a> (downloaded 10/26/2000).					
BT	DS	Tamarack Scientific Co., Inc., "Excimer Laser Photoablation Systems," <a href="http://www.tamsoci.com/ablation.htm">http://www.tamsoci.com/ablation.htm</a> (downloaded 10/31/2000).					
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	EA						
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	EJ						
	EK						
	EL						
<b>FOREIGN PATENT DOCUMENTS</b>							
Exr's. Init.	Ref	Document No.	Date	Country	Class	Sub	Translation? Yes      No
	EM						
	EN						
	EO						
	EP						
<b>OTHER REFERENCES (Including Author, Date, Title, Pertinent Pages, Etc.)</b>							
Exr's. Inits.	Ref.	Bibliographic Data					
BT	EQ	D. Constantinide, "Scanning Projection Lithography for Large Area Substrates," <a href="http://www.tamsci.com/techpadidx.htm">http://www.tamsci.com/techpadidx.htm</a> (downloaded 01/23/2001).					
BT	ER	S. Zhou and M. Kilgo, "Material Removal Rates of Biocompatible Polymers During Laser Ablation," <a href="http://www.tamsci.com/techpadidx.htm">http://www.tamsci.com/techpadidx.htm</a> (downloaded 01/23/2001).					
BT	ES						
Examiner <u>Binh Tran</u>				Date Considered <u>1/22/05</u>			
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